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In the technique of terahertz (THz) frequency time-domain spectroscopy (TDS), THz radiation is generated and detected using femtosecond (fs) near-infrared laser pulses, enabling measurement of both the THz amplitude and phase [1]. In TDS systems, the THz radiation can be generated when the near-infrared fs laser illuminates a GaAs photoconductive antenna [2].

An alternative approach to generate higher THz fields is to amplify THz waves directly after generation, and hence enable low-power fs laser pulses to generate high THz wave amplitudes. THz frequency quantum cascade lasers (QCLs) are natural candidates for THz amplifiers, and enable low-power fs laser pulses to generate high THz field amplitudes, focused in air [4].

In all these cases, the THz field amplitude scales linearly with the power of the fs pulse, until saturation takes place. One strategy to increase further THz field amplitudes is to use higher fs pulse energies, and TDS systems that utilize μJ pulse energies are becoming increasingly common [5]. Although this is a promising laboratory-based technique, it is not practical for applications outside the laboratory owing to the large cost and size of regenerated amplified laser systems.

An integrated injection seeded THz source and amplifier for time-domain spectroscopy

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A terahertz (THz) frequency quantum cascade laser (QCL) is used as an integrated injection seeded source and amplifier for use in THz time-domain spectroscopy. A THz input pulse is generated inside a QCL, by illuminating the laser facet with a near-infrared pulse from a femtosecond laser, and amplified using gain switching. The THz output from the QCL is found to saturate upon increasing the amplitude of the THz input power, which indicates that the QCL is operating in an injection seeded regime. © 2011 Optical Society of America OCIS Codes: 300.6270, 300.6495, 140.5965

In this letter, injection seeding of a QCL is achieved with THz seed pulses that are generated directly inside the QCL cavity. This results in a completely integrated QCL-based source for TDS. Specifically the THz seed pulses are generated inside the QCL cavity [12] by illuminating one of the facets with a near-infrared fs laser beam (Fig 1a). This removes the need to use a photoconductive THz emitter to generate the THz seed pulses and parabolic mirrors to couple the THz seed pulses into the cavity (Fig 1b). Gain switching of the QCL is used to achieve large amplification of the internally generated THz seed pulses. A coupled cavity scheme allows the amplitude of the input seed pulse to be increased without affecting the QCL gain [13, 14]. We find that for sufficient THz seed amplitudes, the amplified seed pulses saturate the QCL gain, which indicates that injection seeding takes place via integrated seed generation.

To enter the injection seeding regime, the amplitude of the THz pulse generated at the facet must be sufficiently large to prevent the QCL from being ‘seeded’ by amplified spontaneous emission. Since the THz pulse amplitude generated at the facet increases with applied voltage [12], it is therefore desirable to apply a large voltage across the facet. However, QCL operation ceases once the applied bias becomes too large owing to misalignment of the injector and upper level laser state. In order to decouple the facet voltage from the QCL bias voltage, focused ion beam (FIB) etching was used to remove a 20 μm wide portion of the gold contact and the heavily-doped n-GaAs contact layer on the top of the laser ridge. This splits the QCL cavity into a short 305 μm seeding section used as the THz pulse generator, and a long 2.5 mm QCL gain section for THz pulse amplification. The resistance between these two sections (~35 Ω) is several times larger than the QCL differential resistance (3-6 Ω). Although, the two sections are not completely electrically isolated: removing the top contact in this way eliminates the need to etch through the entire active region using reactive ion etching [13,14]. As shown in Fig. 1d, independently biased the seeding section decreases the QCL output power. This is most likely due to the leakage current between the seeding and QCL section and increased THz losses in the seeding section. The QCL is based on a
The clamped gain, and permits large amplification [10].

In a transient state where the gain is much greater than the THz laser) is applied to the gain section. This places the QCL generated in the QCL, an RF bias pulse (triggered by the seeding section) biased below threshold. When the THz pulse is generated in the seeding section, the gain before the arrival of the fs pulse (80 fs, 808 nm, 6 nJ) that generates a THz pulse in the seeding section, the gain

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The incident RF pulse (Fig. 1e) is ~6 W, and about 40% of the RF power is injected into the QCL. Faster electronics permit shorter RF rise times and pulse durations compared with studies of external injection seeding [11]. A bias tee also allows the QCL gain section to be biased with a quasi-DC voltage (10 kHz), which reduces the RF power necessary to drive the QCL above threshold. The quasi-DC bias is set to ensure that the RF pulses drive the QCL to the bias at which maximum gain occurs (i.e., just before misalignment of the QCL band-structure). The seeding section is biased at 3.8 V (~180 A/cm²) which roughly corresponds with \( j_{\text{max}} \) in Fig. 1d. The RF pulses and QCL gain section are modulated at 10 kHz (25% duty cycle) while the seeding section is modulated at 20 kHz i.e. at twice the duty cycle of the QCL gain section and RF pulses modulation. This permits lock-in detection of the difference field, which removes the unamplified low frequency components of the THz signal.

Fig. 2 shows the QCL output when the RF drives the QCL above threshold. After the initial THz pulse is generated in the seeding section, it traverses the laser cavity and experiences gain (near the laser frequency) and losses (at other frequencies). At the opposite facet, part of the THz pulse is reflected back into the cavity and part is transmitted out of the QCL. This process will then continue with multiple passes traveling through the cavity. The output of the QCL thus consists of several THz pulses modulation. This permits lock-in detection of the difference field, which removes the unamplified low frequency components of the THz signal.

As shown in Fig. 2a, the THz pulses separated by the round-trip time (~71 ps) of the cavity. A pair of parabolic mirrors collimates and focuses the transmitted THz pulses onto a 200-μm-thick <110> ZnTe crystal for electro-optic detection.

As shown in Fig. 2a, the THz pulses undergo large amplification when the RF pulse brings the QCL bias above threshold and unclamps the gain. Figs. 2b and 2c are zoomed in portions of the 1st and 4th THz pulses in Fig 2a, that show the phase-resolved nature of the measurement in Fig. 2a. After three round-trips the difference field is amplified by more than a factor of 80, and the output field is almost two orders of magnitude larger than the input field. The amplified THz emission lasts for approximately the same time as the RF pulse duration in Fig. 1e. Since there is no significant reflection between the seeding section and the gain section, no secondary THz seed pulses are produced. Although later THz pulses undergo dispersion, the THz pulses remain...
distinct. The maximum peak-to-peak field (40 V/cm corresponding to an intensity of 1.8 W/cm²) is significantly greater than studies of external injection seeding on a 2.1THz QCL [11], and is due to the higher output powers of the 2.5THz devices (~20mW) compared to the 2.1THz device (1.5mW). From the ratio of the spectral amplitudes of successive THz pulses in Fig. 2a, we can find the average difference between the unclamped gain and the clamped gain, which we define as the excess gain. A positive excess gain will result in a net amplification of a pulse that undergoes a round-trip through the QCL cavity. The largest value of the average excess gain (at the laser frequency) is 9 cm⁻¹ and occurs between the 2nd and 3rd pulses in Fig. 2a.

To determine if the THz input pulses saturate the QCL gain (and are thus injection seeding the QCL), the output QCL field can be studied as function of the input THz pulse amplitude by varying the voltage applied to the seeding section. The peak-to-peak fields of the 1st, 5th and 6th output THz pulses are plotted in Fig. 3 as a function of the seeding section voltage. The 1st output THz pulse corresponds to a single pass through the cavity. Although the THz radiation generated at the facet cannot be directly measured, it is proportional to the amplitude of the 1st emitted THz pulse. The amplitude of this pulse increases almost linearly for seeding section voltage less than 3.5 V. For higher voltages, the input amplitude continues to increase with seeding section voltage although the slope decreases slightly. When the seeding section voltage (and hence the amplitude of the generated THz pulse) is small, the peak-to-peak field of the 5th and 6th pulses also increases with voltage. However, for large seeding voltages the peak amplitudes of the 5th and 6th pulses are flat even though the amplitude of the 1st pulse keeps increasing. This indicates that the gain of the laser is saturated (clamped) by the amplified THz pulses, and the laser emission has entered the injection seeded regime.

In conclusion, we have demonstrated an integrated QCL-based source of THz radiation suitable for TDS. THz pulses are generated directly inside a coupled-cavity QCL by illuminating the facet with fs near-infrared laser pulses, and are subsequently amplified to high field values using gain switching until injection seeding of the QCL is achieved. The THz signal generated in the seed element is thus increased by amplifying the THz wave using the high gain available from the QCL gain section, rather than by increasing the fs laser power. Decoupling the strength of the THz signal from the fs laser power could make TDS more practical by reducing the need for higher power fs lasers.

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# References


